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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/3577.X1/DSM/ BCVD/JW	Serial No. 09/336,525
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Judy Huang	Confirmation No. 7748
(Use several sheets if necessary)		Filing Date June 18, 1999	Group 1762
	Examiner M. Padgett		

U.S. Patent Documents

*Examiner Initial	Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
<i>JHP</i>	A1 5,869,147	02/09/1999	König	427	537	04/01/1995
	A2					
	A3					
	A4					
	A5	BEST AVAILABLE COPY				
	A6					
	A7					
	A8					
	A9					
	A10					

Foreign Patent Documents

*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						YES	NO
<i>JHP</i>	B1 EP 0 785 475 A2	07/23/1997	Europe	G03G	5/082	In English	X
<i>JHP</i>	B2 EP 0 194 652	09/17/1986	Europe	C23C	14/06	II	X
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	B4						

OTHER ART

*Examiner Initial	Including Author, Title, Date, Pertinent Pages, Etc.	
<i>MJP</i>	C1	Youngsoo Park, et al., Institute of Electrical Engineers, "Endothermic reactions between mullite and silicon carbide in an argon plasma environment," <u>Journal of American Ceramic Society</u> , USA, Jan. 1988, American Ceramic Soc., USA, Vol. 81, No 1, pp. 233-236, XP-002201865. <i>Abstract only supplied</i>
<i>MJP</i>	C2	Tremblay, Marc, et al., "Hexagonal Sensor with Imbedded Analog Image Processing for Pattern Recognition," <u>IEEE 1993 Custom Integrated Circuits Conference</u> , May 9, 1993, pp. 12701-12704, XP-000409694.
	C3	Partial European Search Report from EP 00 10 9917, dated July 3, 2002. <i>NOT applicable</i>
Examiner <i>M. Padgett</i>		Date Considered 9/30/02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.